

Form PTO-1449

Docket Number (Optional)

Application Number

TSMC-00-488

10/791,014

Applicant

Chung-Shi Liu et al.

Filing Date

03/02/04

Group Art Unit

INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

(Use several sheets if necessary)

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
SW	6008120	12/28/99	Lee	438	634	12/1/98
	6103601	8/15/00	Lee et al.	438	513	6/10/99
	6121164	9/19/00	Yieh et al.	438	790	10/24/97
	6130157	10/19/00	Liu et al.	438	669	7/16/99
✓	6136680	10/24/00	Lai et al.	438	597	1/21/00
	6150272	11/21/00	Liu et al.	438	692	11/16/98

## FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Portmorf Pages, Etc.)


EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.